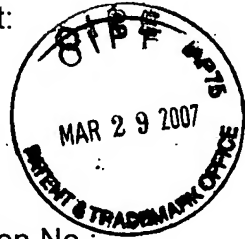


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Masashi GOTO *et al.*

Title: DIELECTRIC FILM, ITS FORMATION METHOD,
SEMICONDUCTOR DEVICE USING THE DIELECTRIC
FILM AND ITS PRODUCTION METHOD



Application No.: 10/726,870

Filing Date: 2 December, 2003

Examiner/Unit: Dao H. Nguyen / 2818

Attorney Docket No.: 2204-011-03

CERTIFICATE OF MAILING

I hereby certify that this communication, and any document being attached hereto, is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450

on this 26th day of March 2007.

[Handwritten signature]

Signature

RESPONSE TO OFFICE ACTION

TO COMMISSIONER FOR PATENTS

This paper is filed in response to the Office Action dated 25 October 2006. Applicants request that the Examiner please amend and reconsider the application in view of this communication.

Amendments to the Specification begin on page 2 of this paper,

Amendments to the Claims are reflected in the listing of claims that begin on page 3 of this paper, and

Remarks begin on page 7 of this paper.